

Notice of References Cited	Application/Control No. 10/615,062	Applicant(s)/Patent Under Reexamination KWON, HYUG-JIN	
	Examiner Sylvia R. MacArthur	Art Unit 1763	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0173068	08-2005	Chen et al.	156/345.33
*	B	US-2003/0213436	11-2003	Kwon, Hyung-Jin	118/725
*	C	US-2003/0121608	07-2003	Chen et al.	118/715
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	I	US-			
	J	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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